

U.S.S.N. 10,656,584

RECEIVED
CENTRAL FAX CENTER
JUL 26 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hsu et al.

Group Art Unit: 1765

Serial No.: 10,656,584

Examiner: Tran, Binh X

Filed: 09/04/2003

In Response to Office Action
Dated: 04/27/2005

For: PLASMA TREATMENT METHOD TO REDUCE SILICON

EROSION OVER HDI SILICON REGIONS

Attorney Docket No.: 67,200-1117

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certify that this correspondence is (1) being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on July 26, 2005; or (2) being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571) 273-8300 on July 26, 2005.

Randy W. Tung
Printed Name

Signature

7/26/05

Date

Please forward all correspondence to
TUNG & ASSOCIATES
838 W. Long Lake Road, Suite 120
Bloomfield Hills, MI 48302

BEST AVAILABLE

1

07-26-'05 15:02 FROM-TUNG & ASSOCIATES

12485404035

T-368 P04/26 U-586

RECEIVED
CENTRAL FAX CENTER

U.S.S.N. 10,656,584

JUL 26 2005

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 04/27/2005,
please enter the following amendments and consider the following
remarks.